

Prober and Probe Card Analyzer Performance Under Load

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Presentation Agenda

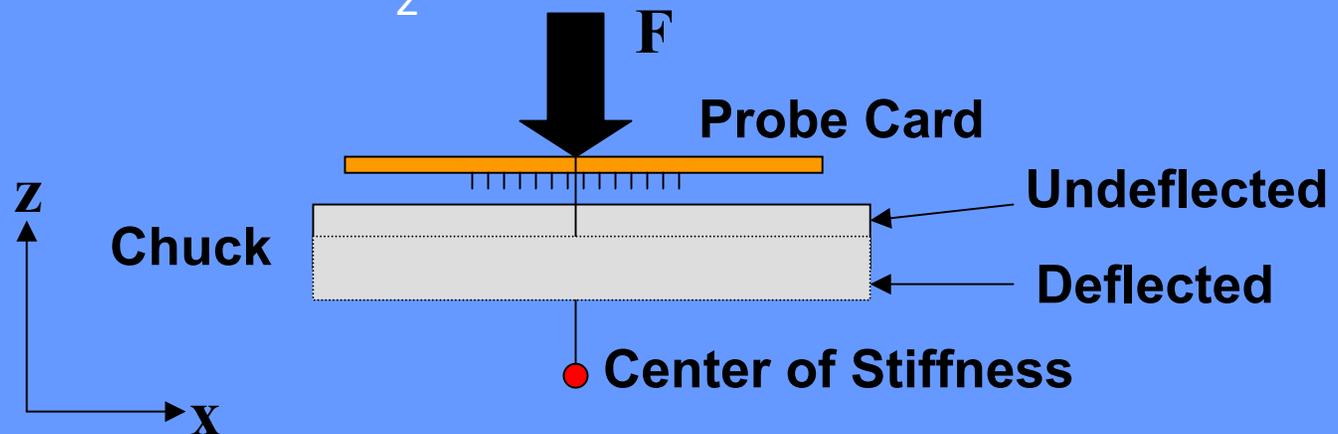
- Motivation
- Loads and Deflection Mechanisms
- Probe Tip Mechanics
- Loaded Prober and Probe Card Analyzer (PCA) Performance
- Summary and Conclusions

Motivation

- Increasing Loads + Tighter Accuracy
 - No matter how stiff we design stages, if we're driven to scrutinize closely enough, we'll always see the effects of deflection under load
 - Deflection can impact yield
 - \Rightarrow Deflection under load increasingly important
- Presentation Objective:
 - Understand manifestations of deflection under load to aid problem identification
 - Suggest means of reducing effects of deflection under load

Normal Loads and Deflections

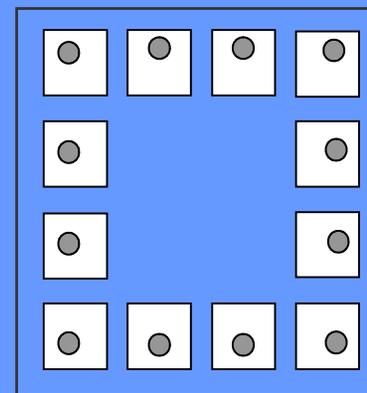
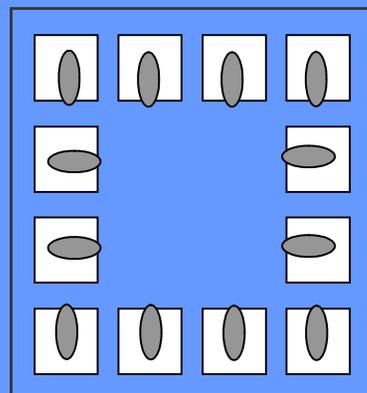
- Direction: Perpendicular to wafer and probe array surface
- Origin: Probe tip stiffness
- Generally linear with overtravel
- Vertical probe technology can be non-linear
- z-direction compliance \Rightarrow z-direction deflection
- Deflection: $\Delta z = F c_z$



Normal Loads and Deflections

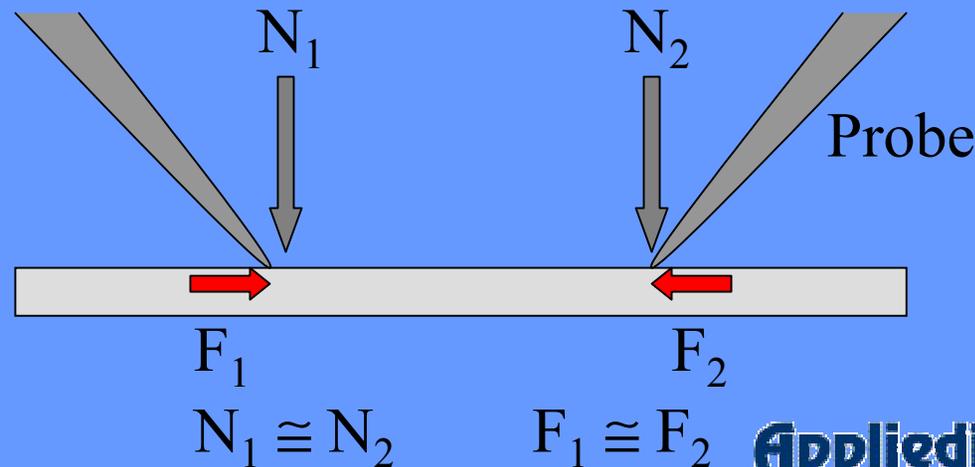
- Normal load effects on scrub
 - z-deflection reduces overtravel \Rightarrow shorter scrubs
 - Normal force reduced
 - Overtravel can be adjusted to account for expected compliance
 - Adjustment errors produce longer or shorter scrubs

Overcompensated Overtravel **Undercompensated Overtravel**



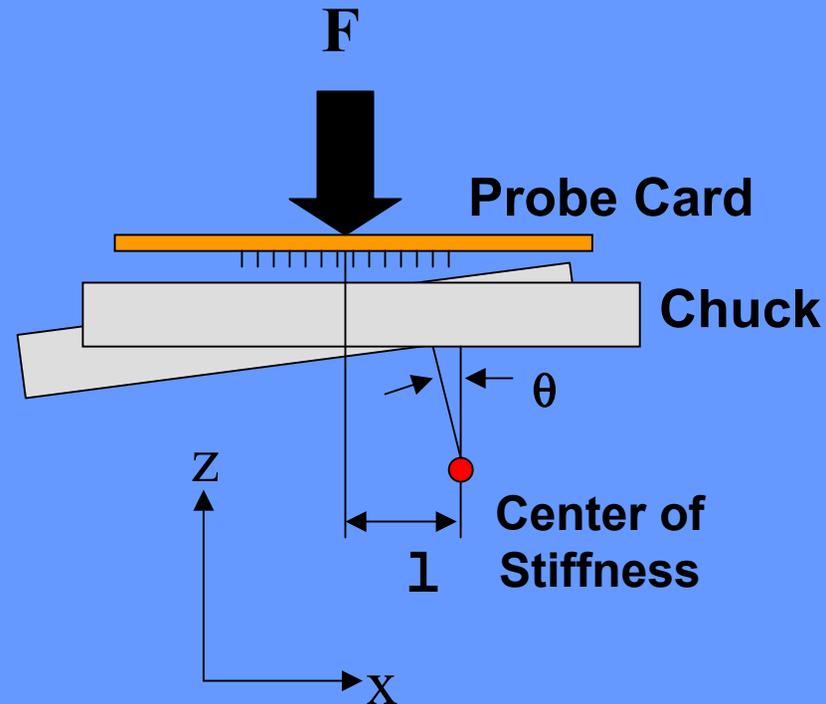
Transverse Loads and Deflections

- Transverse Loads
 - Direction: In-plane
 - Origin: Probe tip friction
 - Symmetry: Transverse loads largely cancel on average
 - Potential for deflection-induced errors with asymmetric probe orientations



Torsional Loads and Deflections

- Origin: Center of load does not pass through center of stiffness
- \Rightarrow Rotation about center of stiffness
 - Torque: $T = F l$
 - Rotation: $\theta = F l c_{rot}$
- Effects:
 - Dependent on center of stiffness
 - Lateral deflection - often dominant
 - Vertical deflection



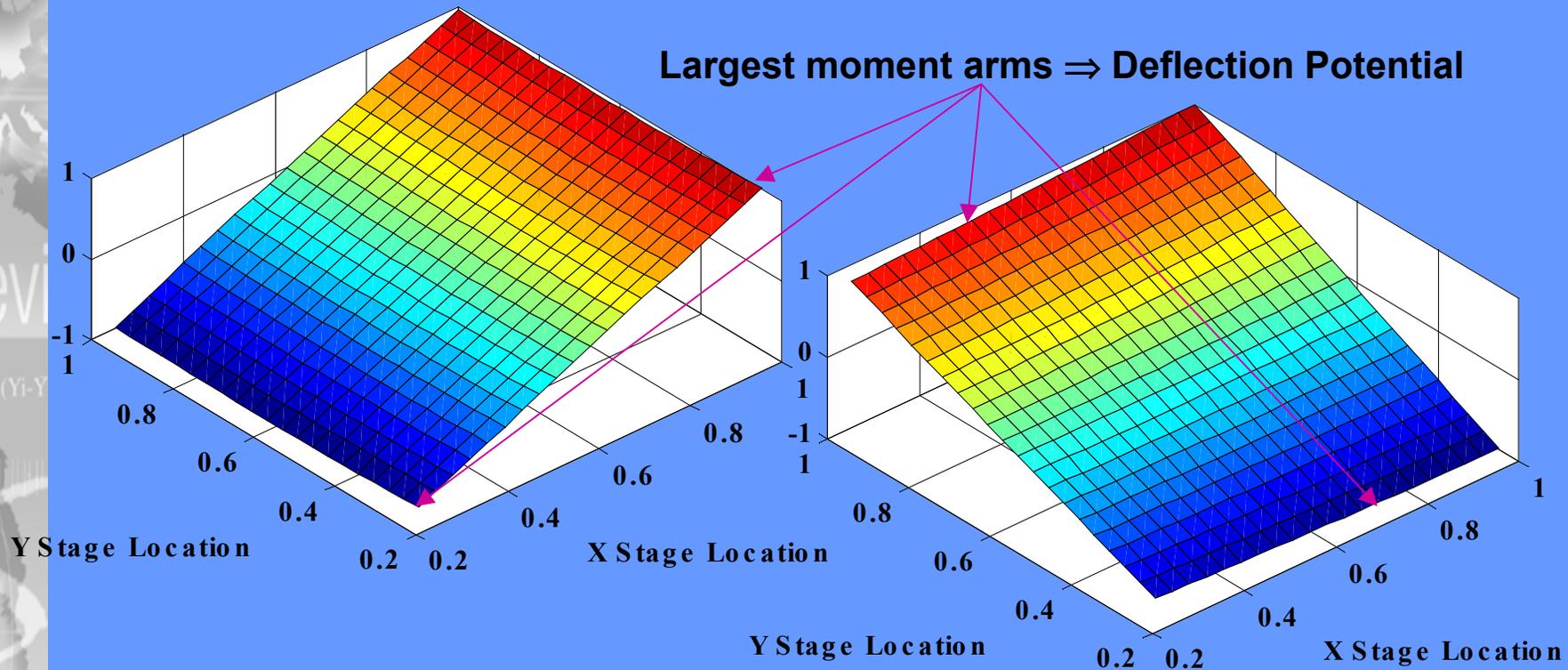
Center of Stiffness Offset

Normalized Offset Relative to Center of Force

Goal: Minimize Offset

X Center of Stiffness Offset

Y Center of Stiffness Offset

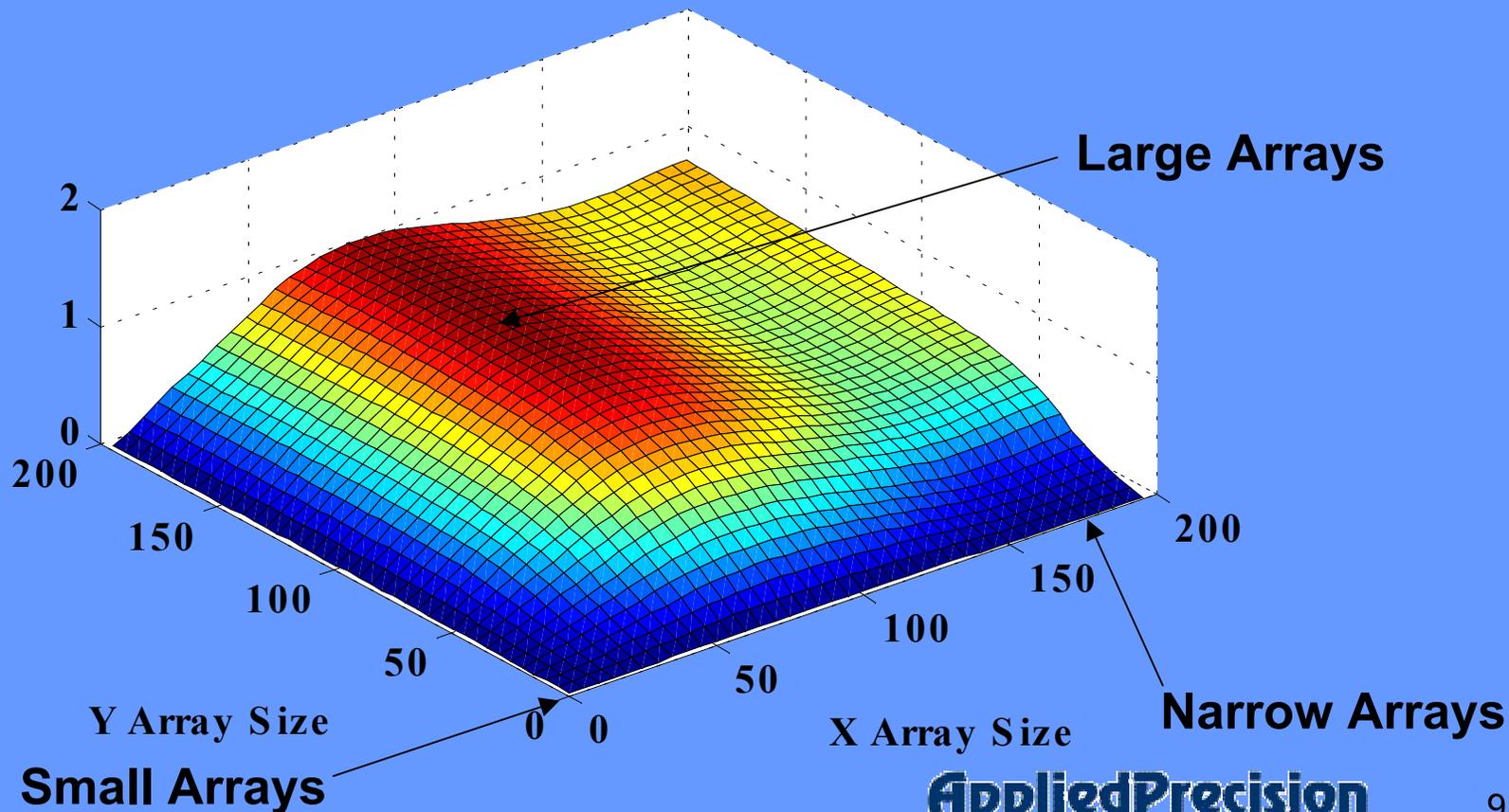


Chuck Deflection from Torsion

3 σ Normalized Scrub Alignment Variation Under Load vs Array Size

- **Factors**

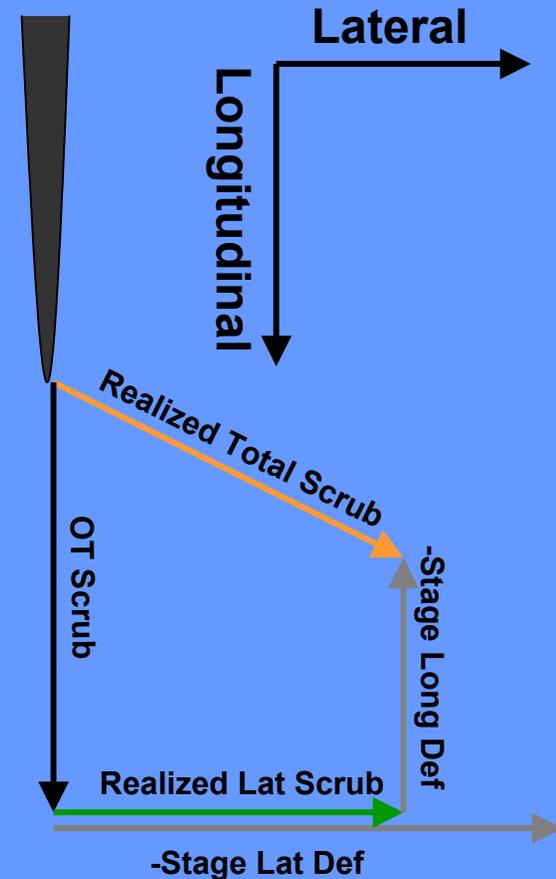
- **Array size**
- **Number of pins on chuck**
- **Center of load relative to stiffness**



Probe Geometries

- Cantilever Probes
 - Longitudinal deflection
 - Stiff axis
 - 1:1 deflection into scrub
 - Lateral deflection
 - More flexible axis
 - Probes tend to drag somewhat - reduces sensitivity to deflection effects
 - <1:1 deflection into scrub
 - 0.3:1 common

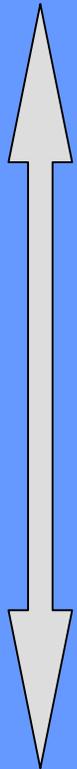
Top View



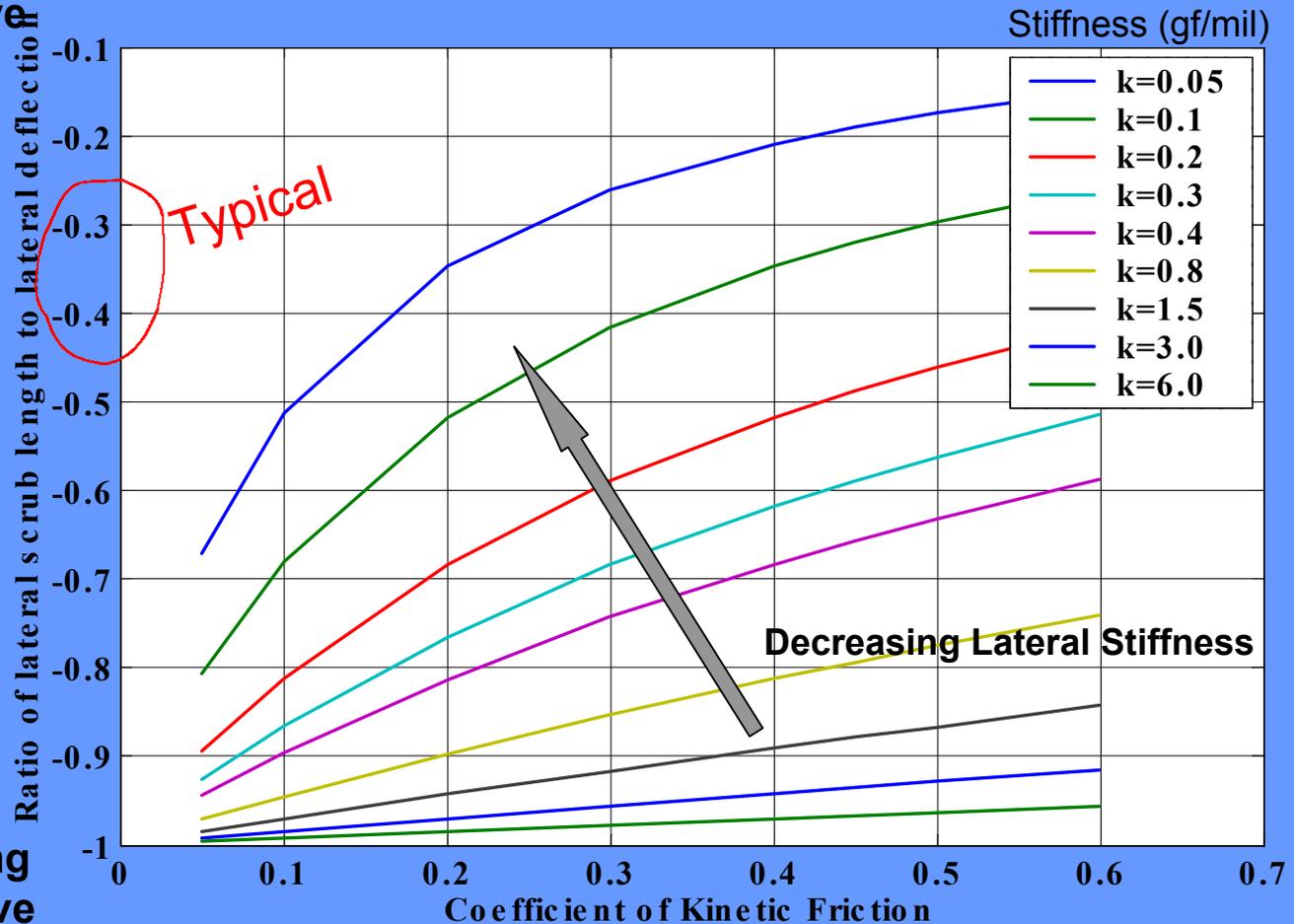
Cantilever Probe Lateral Deflection

Effects of Friction and Lateral Probe Stiffness on Lateral Deflection

More Dragging
Less Sensitive



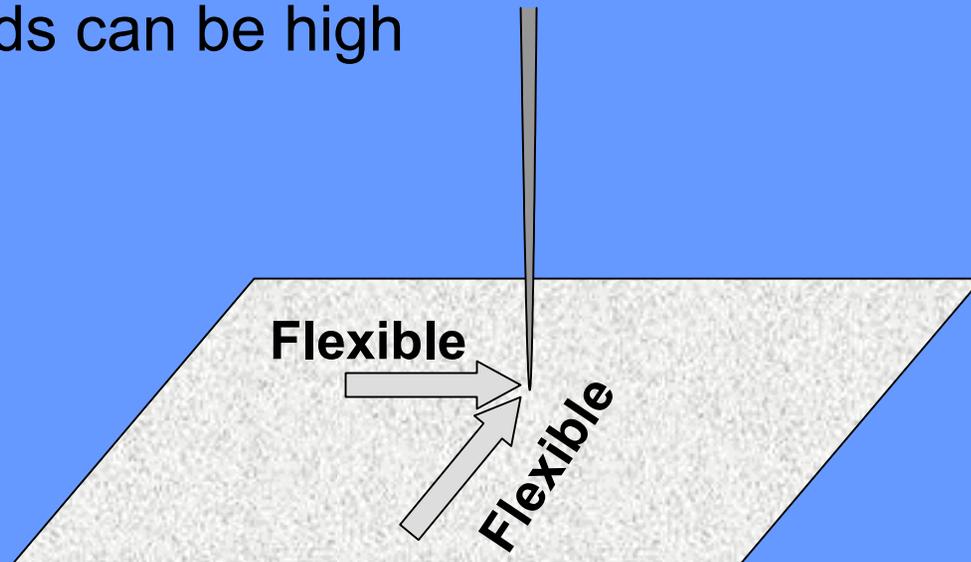
Less Dragging
More Sensitive



Probe Geometries

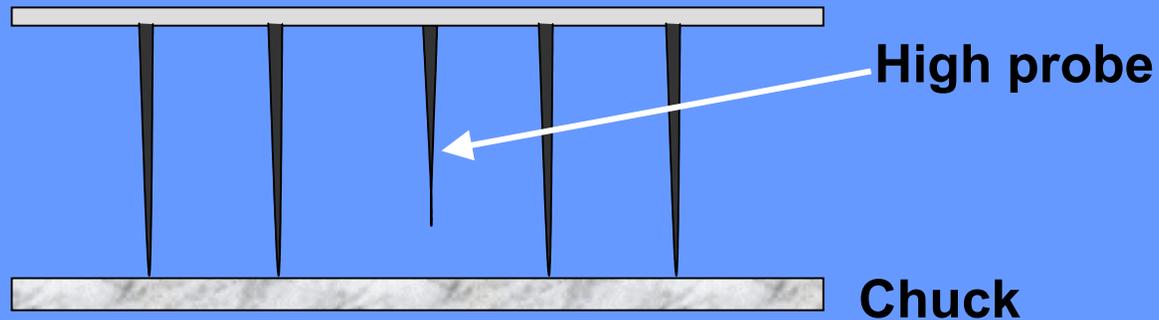
- Vertical Probes

- Relatively compliant with respect to in-plane forces (e.g. friction)
- Probes are “dragged” with chuck as it deflects
- Deflection induced error governed by high probes
- Highly planar arrays forgiving of deflection even though loads can be high

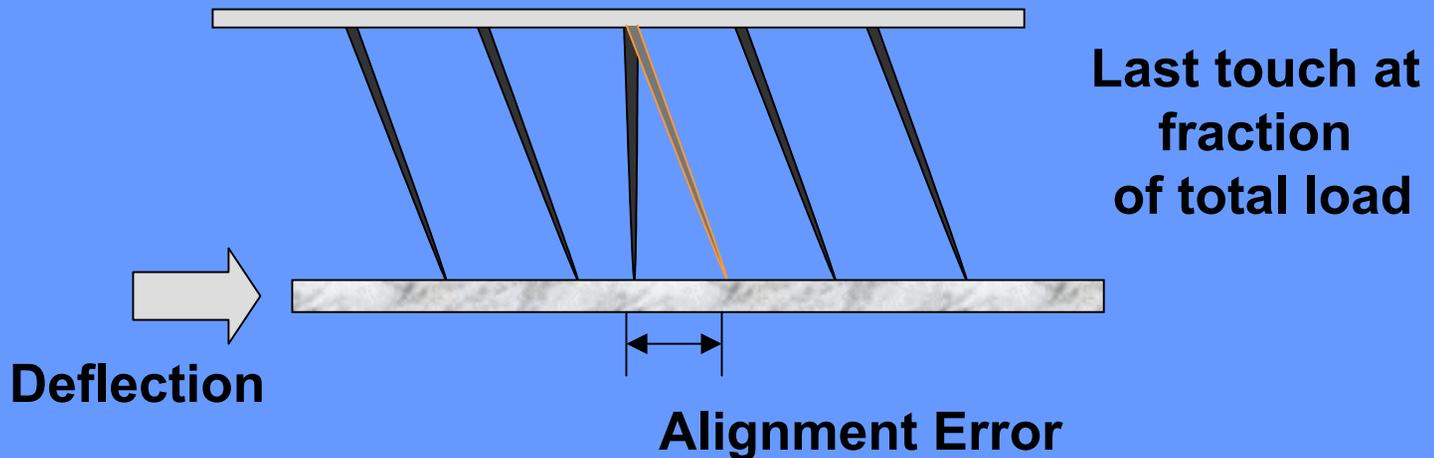


Vertical Probes: Deflection Effects

First Touch



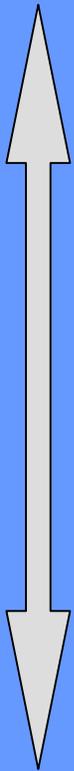
Last Touch



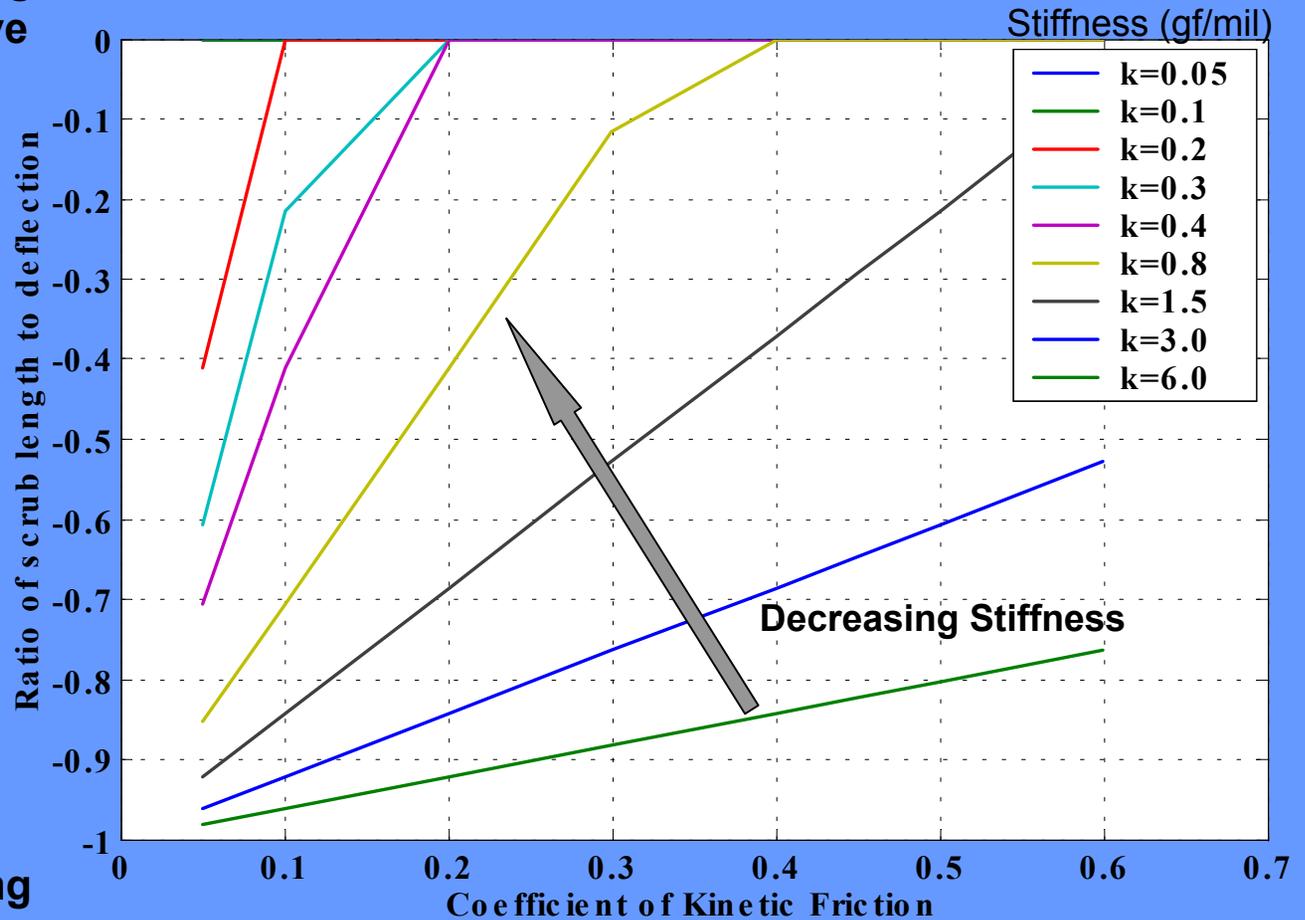
Vertical Probe Deflection

Effects of Friction and Probe Stiffness on Deflection

More Dragging
Less Sensitive

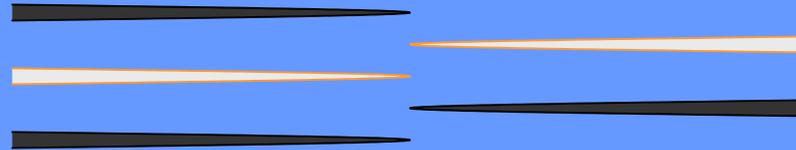


Less Dragging
More Sensitive



PCA: Cantilever Deflection Estimation

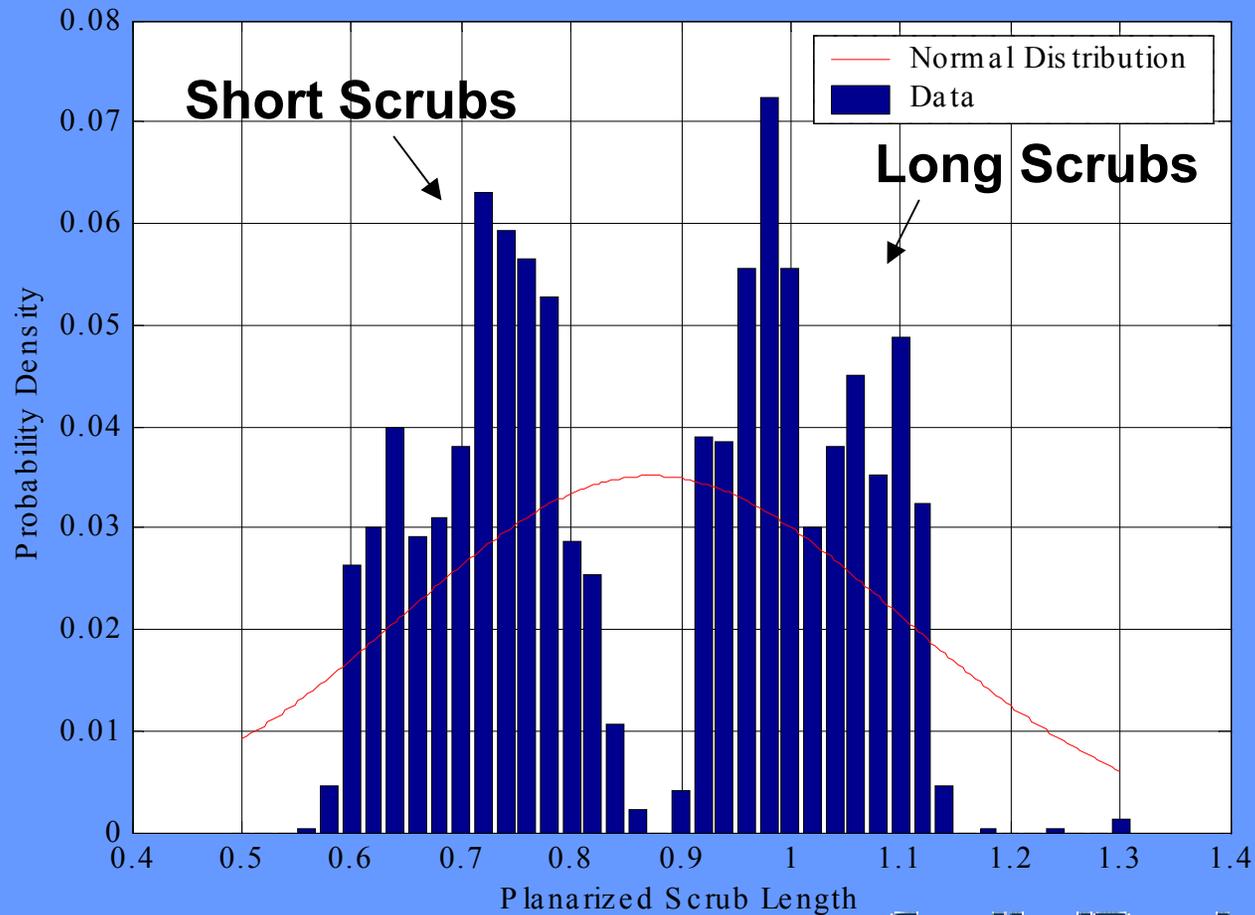
- Co-located, opposing probes



- Co-located \Rightarrow Equiv loads, Equiv deflections for PCA
 - Equal and opposite variations in scrub length
 - Equal and opposite variations in scrub angle
 - Data can be used to estimate deflection
- Deflection \Rightarrow bimodal distribution of scrub length and/or scrub angle
 - Dependent on compliance in each axis

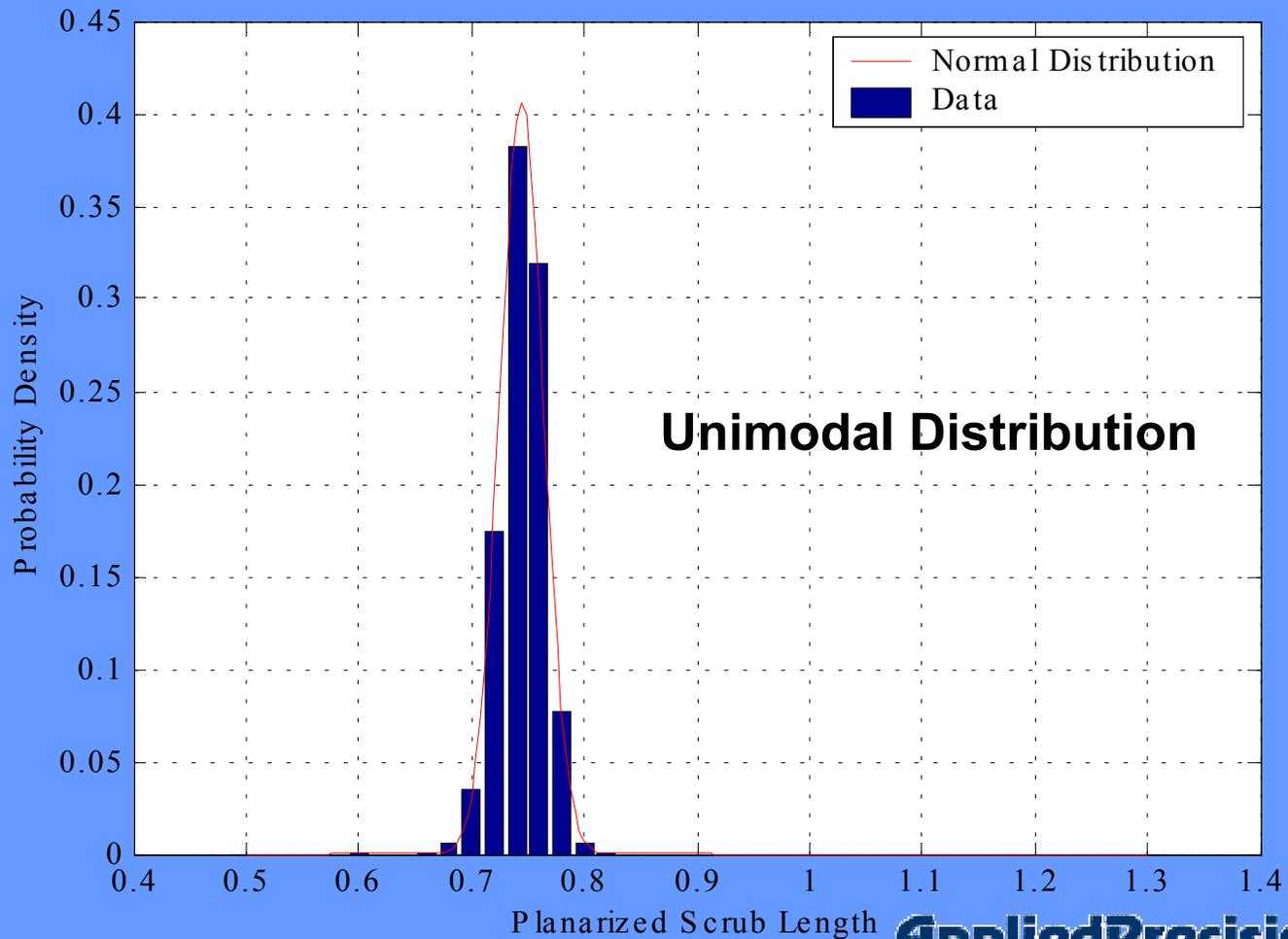
Cantilever: Statistical Distribution

High Stage Compliance in Scrub Direction Normalized Scrub Length Distribution



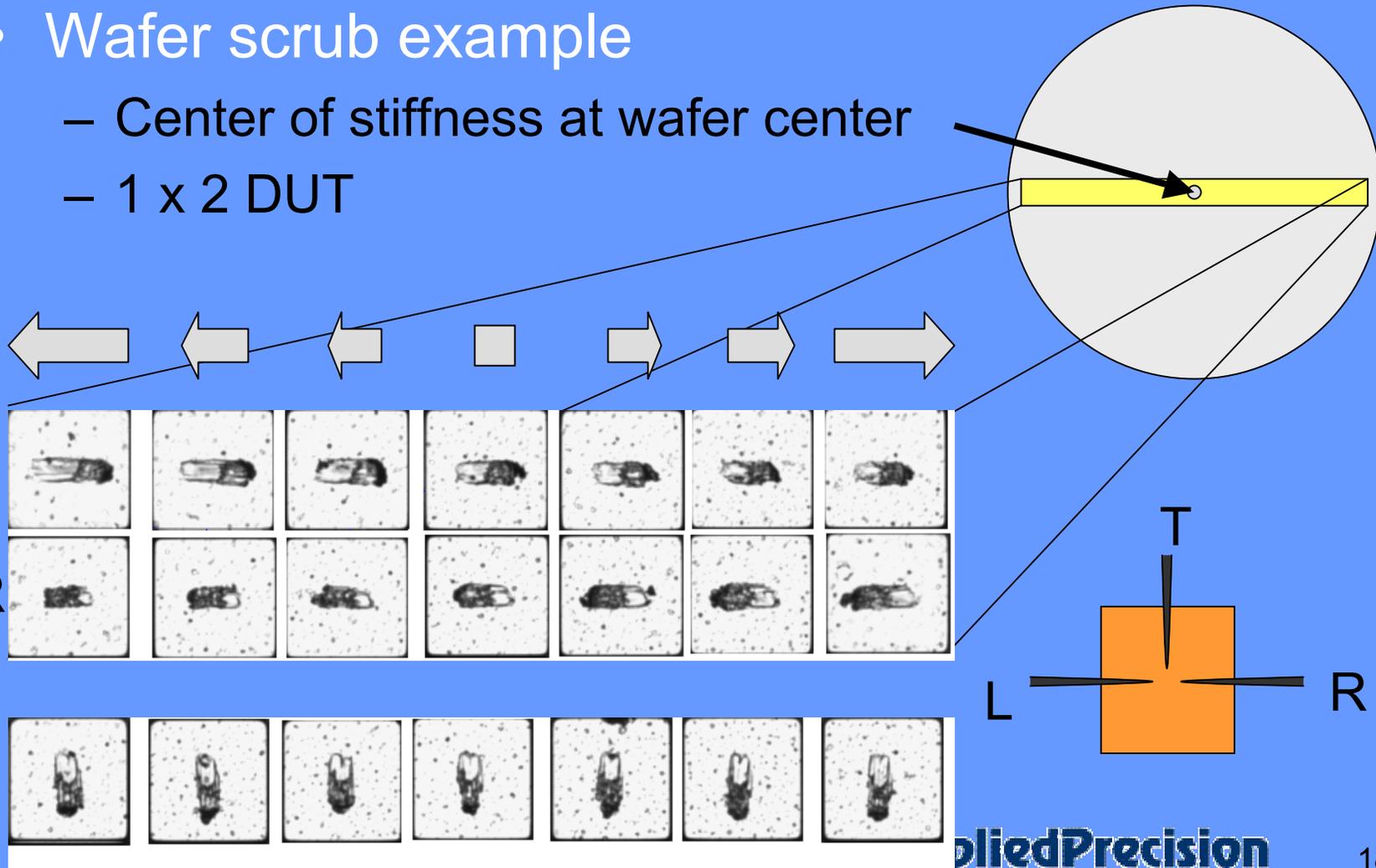
Cantilever: Statistical Distribution

Low Stage Compliance in Scrub Direction Normalized Scrub Length Distribution



Prober: Cantilever Scrubs

- Rotation under torsional load \Rightarrow lateral deflection
- Wafer scrub example
 - Center of stiffness at wafer center
 - 1 x 2 DUT



Deflection Compensation

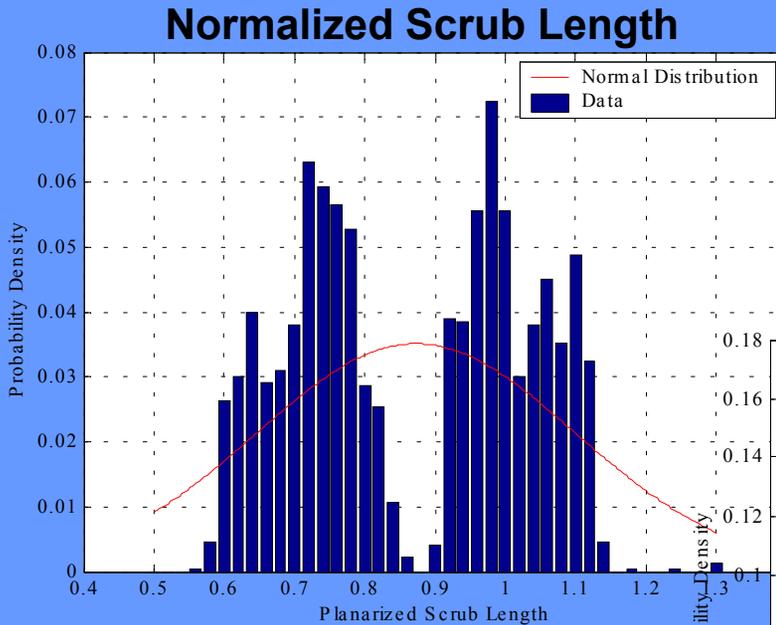
- Modeling & Estimation
 - Model chuck compliance as a function of location
 - Experimentally determine load/displacement influence coefficient map
 - Estimate influence coefficients based on known component values and FEA
 - Model probe loads
 - Nominal probe gram force parameter and overtravel
 - Calculate total load and load centroid
 - \Rightarrow Estimate Chuck Deflection

Deflection Compensation

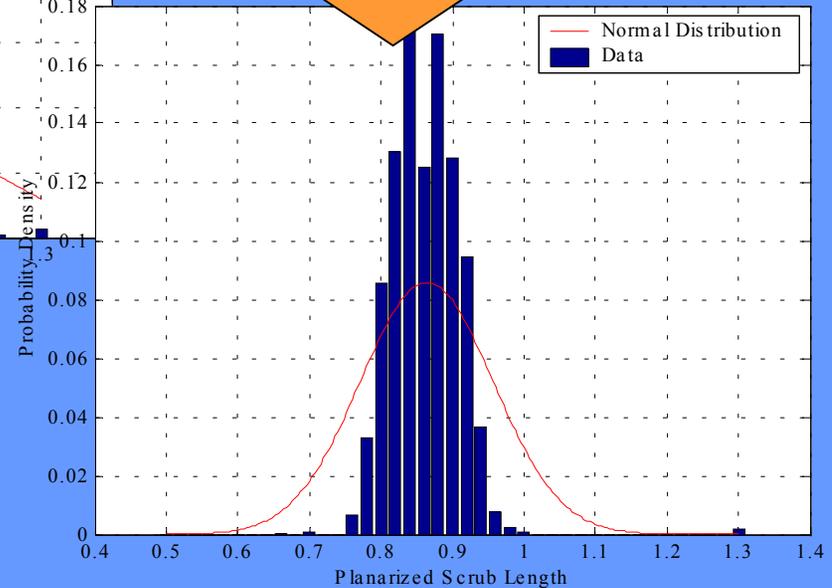
- **Passive Compensation**
 - Post-process results, and remove estimated deflection from measurements
 - Possible only for PCA's
- **Active Compensation**
 - Actively translate chuck using deflection estimates
 - Estimate real-time loads and deflections
 - Any prober compensation needs to be active

Deflection Compensation

- Deflection Compensation Example



Un-Compensated



Compensated

Conclusions

- Ways to reduce probe scrub errors:
 - Cantilever and Microspring Technology
 - Reduce probe gram force and overtravel
 - Minimize distance from chuck center of stiffness to center of load
 - Optimize card orientation: align probes with least compliant axis if possible
 - Reduce chuck compliance

Conclusions

- Ways to reduce probe alignment errors
 - Vertical Technology
 - Tighten probe card planarity if possible
 - Minimize distance from chuck center of stiffness to center of load
 - Reduce probe gram force
 - Minimize chuck compliance
 - Overtravel not a significant factor

Conclusions

- Deflection under load increasingly important issue
- Deflection can be estimated from standard test data, and quantified
- Deflection may be minimized proactively in a number of ways
- Deflection effects may be minimized via compensation